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10587592 - GAI: 1792

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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> ( Not for submission under 37 CFR 1.99)	Application Number		10587592	
	Filing Date		2006-07-28	
	First Named Inventor	Tomomi MEGURO et al.		
	Art Unit	1792		
	Examiner Name	Talbot, Brian		
	Attorney Docket Number	81844.0051		

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3	1775491	SU	A1	1992-11-15	Borislavskij	<input type="checkbox"/>
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	1	Lau et al. "Growth of epitaxial ZnO Thin Films by Organometallic Chemical Vapor Deposition" Journal of Electrochemical Society, Electrochemical Society. Manchester, News Hamshire, Vol. 127. No. 8, pp. 1843-1847, 1980 <b>No month available</b>	<input type="checkbox"/>
	2	Li et al. "Growth of High Quality ZnO Thin Films at Low Temperature on Si(100) Substrates by Plasma Enhanced Chemical Vapor Deposition" Journal of Vacuum Science and Technology: Part A AVS/AIP, Melville, Vol. 20, No. 1, 2002 <b>No month available</b>	<input type="checkbox"/>
	3	Haga et al. "ZnO Thin Films Prepared by Remote Plasma-Enhanced CVD Method" Journal of Crystal Growth, Amsterdam, NL, Vol. 214-215, pp. 77-80, 2000 <b>No month available</b>	<input type="checkbox"/>
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